



ELECTRONIC COPY

LG762544229
Report verification at igi.org



January 22, 2026

IGI Report Number **LG762544229**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.99 - 8.04 X 4.75 MM**

GRADING RESULTS

Carat Weight **1.90 CARAT**

Color Grade **G**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

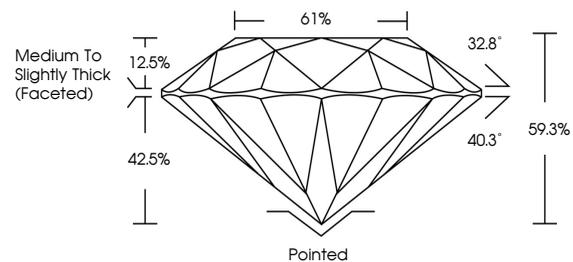
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG762544229**

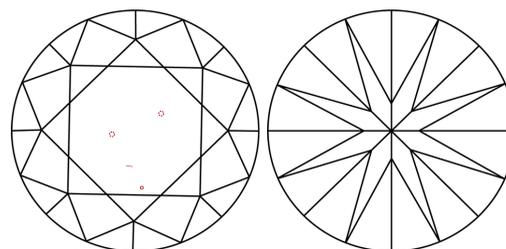
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

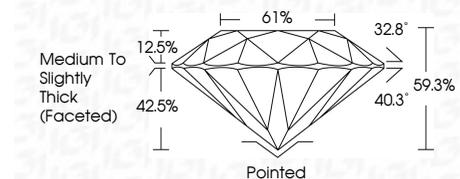
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Fluorescence **NONE**

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ROUND BRILLIANT

1.90 CARAT
Color Grade G
Clarity Grade VS 1
Depth 59.3%
Table 12.5%
Girdle 61%
Medium To Slightly Thick (Faceted)

Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscriptions(s) IGI LG762544229

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